

View Online at <https://aerobasegroup.com/nsn/6630-01-291-7548>

General Description:

For anisotropic etching of electron devices for failure analysis laboratories; built-in vacuum gauge, built-in pyrex chamber (replacable) w/lift-top design for easy loading and two gas valves making possible the mixing of 2 reactive gasses when desired

Shelf Life:

N/a

Unit Of Measure:

--

Demilitarization:

No